

**Temporal characteristics of the  
UVSOR storage ring FEL**

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- Storage ring free electron laser experiment at UVSOR
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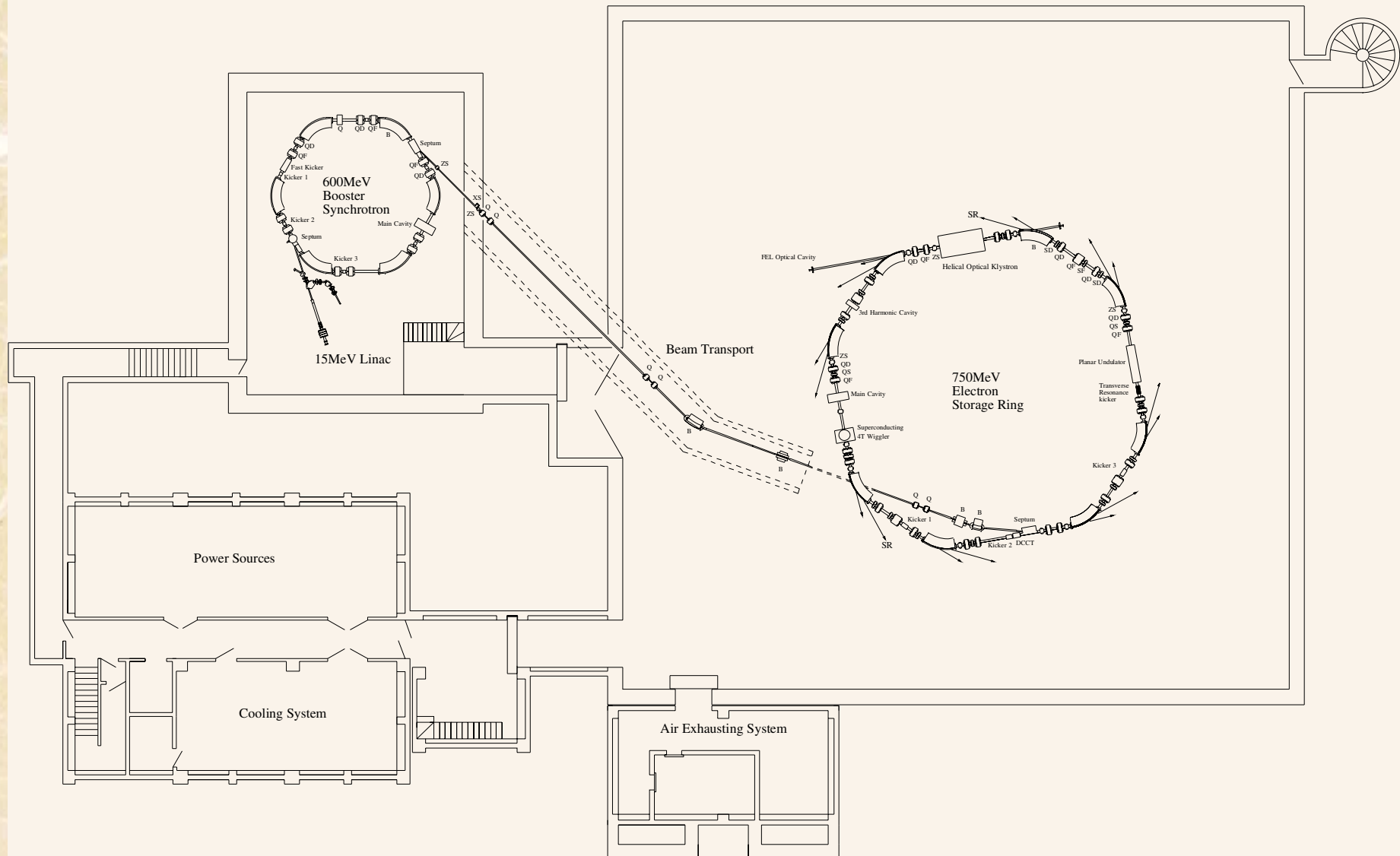


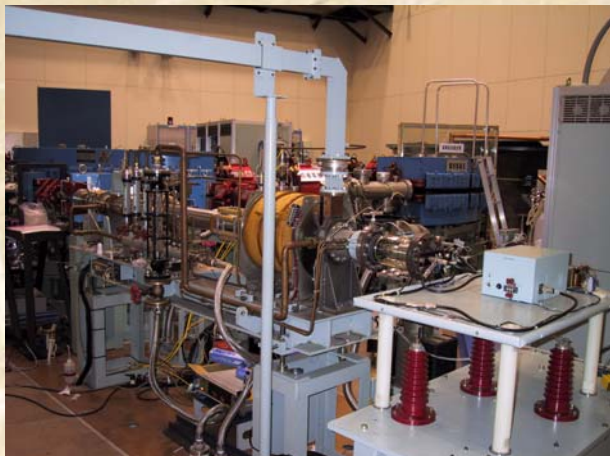
UVSOR-II storage ring since 2003

Circumference	53.2 m
Beam Energy	750 MeV
Critical Photon Energy	425 eV
RF Frequency	90 MHz
Harmonic Number	16
RF Voltage	55 kV
Emittance	27.5 nmrad

# UVSOR accelerator complex

Plane view of the UVSOR Facility

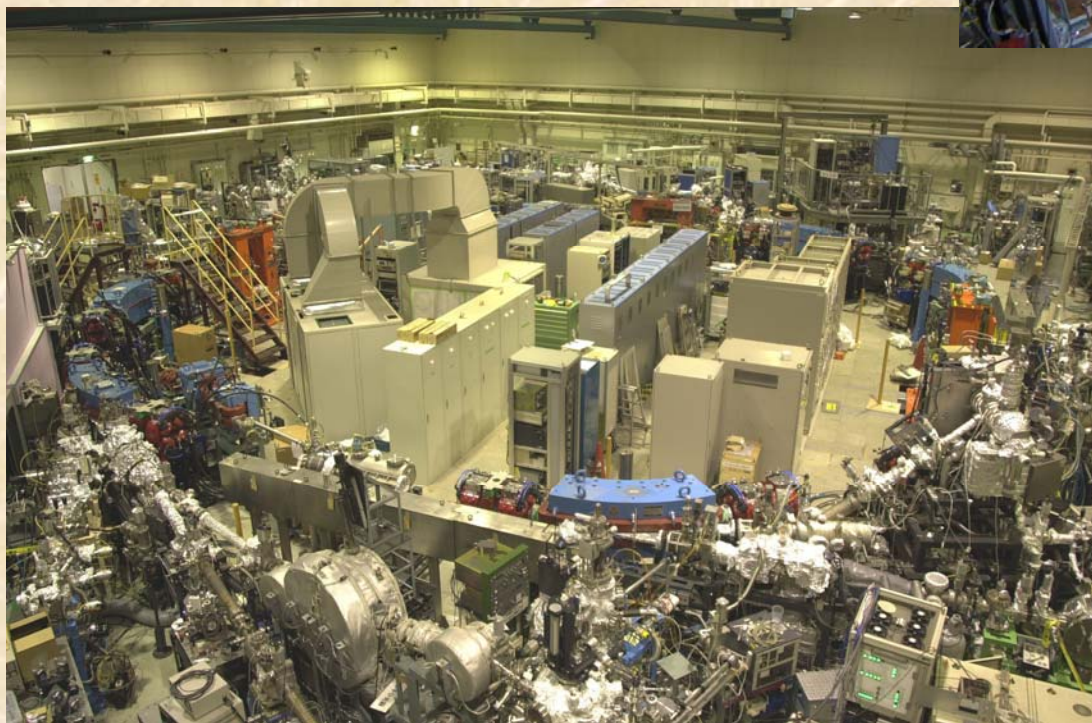




*Injection 15 MeV-linac*



*Booster 600 MeV-Synchrotron*



*750 MeV Storage Ring*

# Storage ring free electron laser experiment at UVSOR

## History of UVSOR-FEL

1993 First Lasing

1996 Installation of a helical optical klystron

Lasing of 239 nm

Gamma ray via Compton backscattering

2000 1<sup>st</sup> User experiment

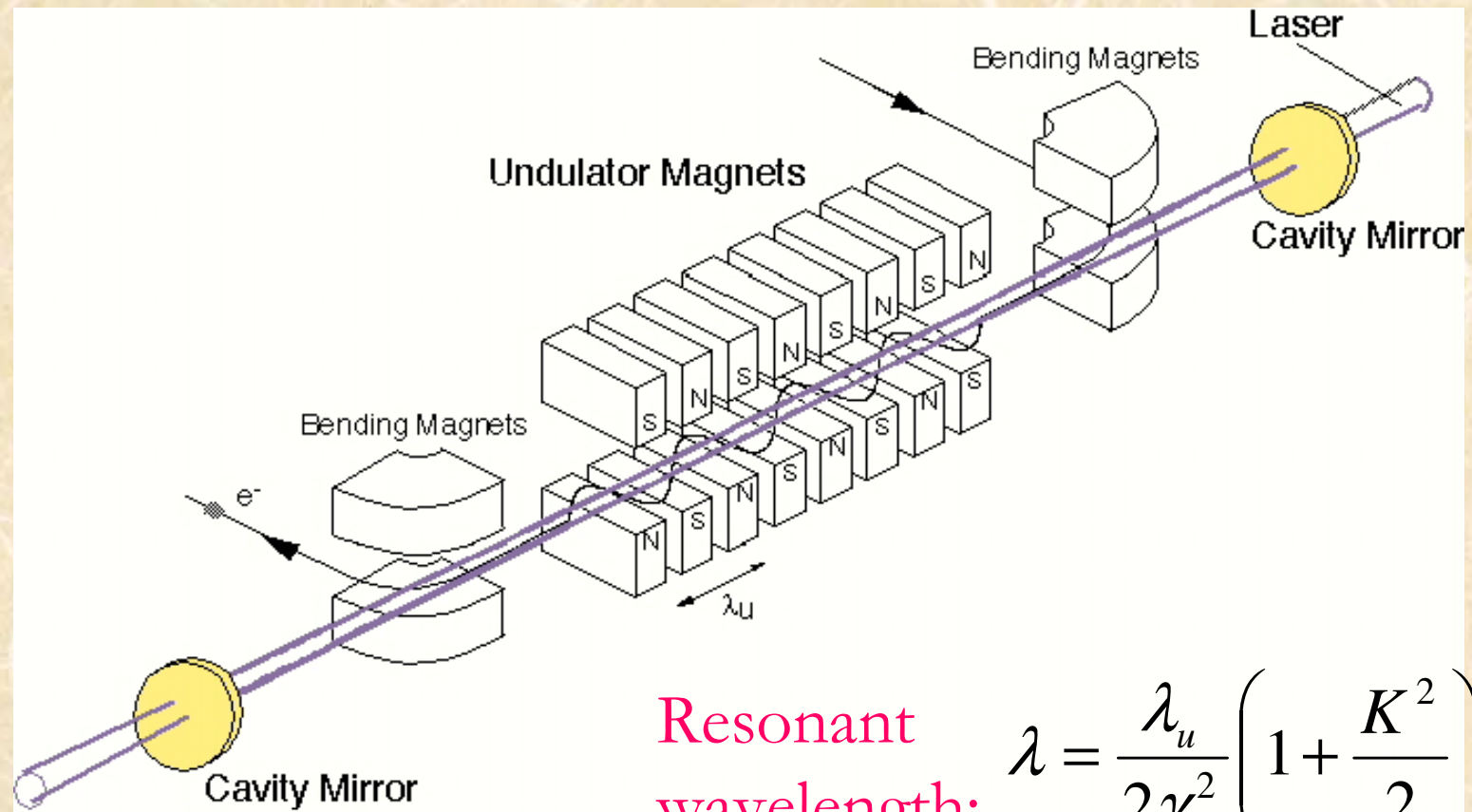
2001 FEL Power 1.2 W ( $\lambda=570$  nm)

2003 Upgrade of the UVSOR storage ring

2004 P > 0.2 W ( $\lambda=250$  nm)

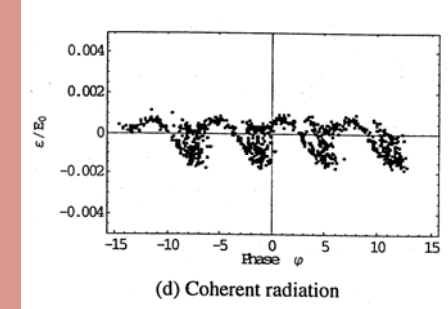
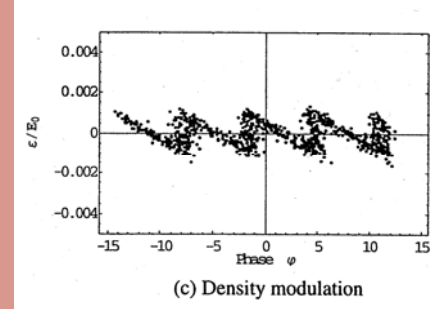
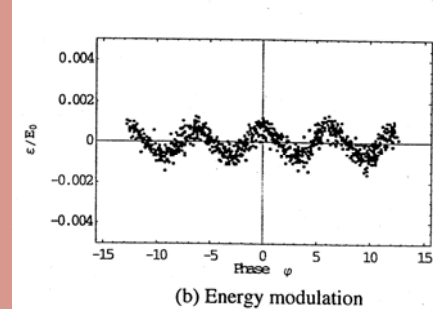
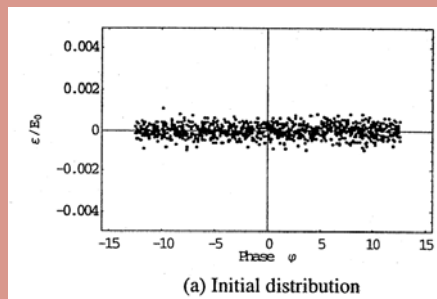
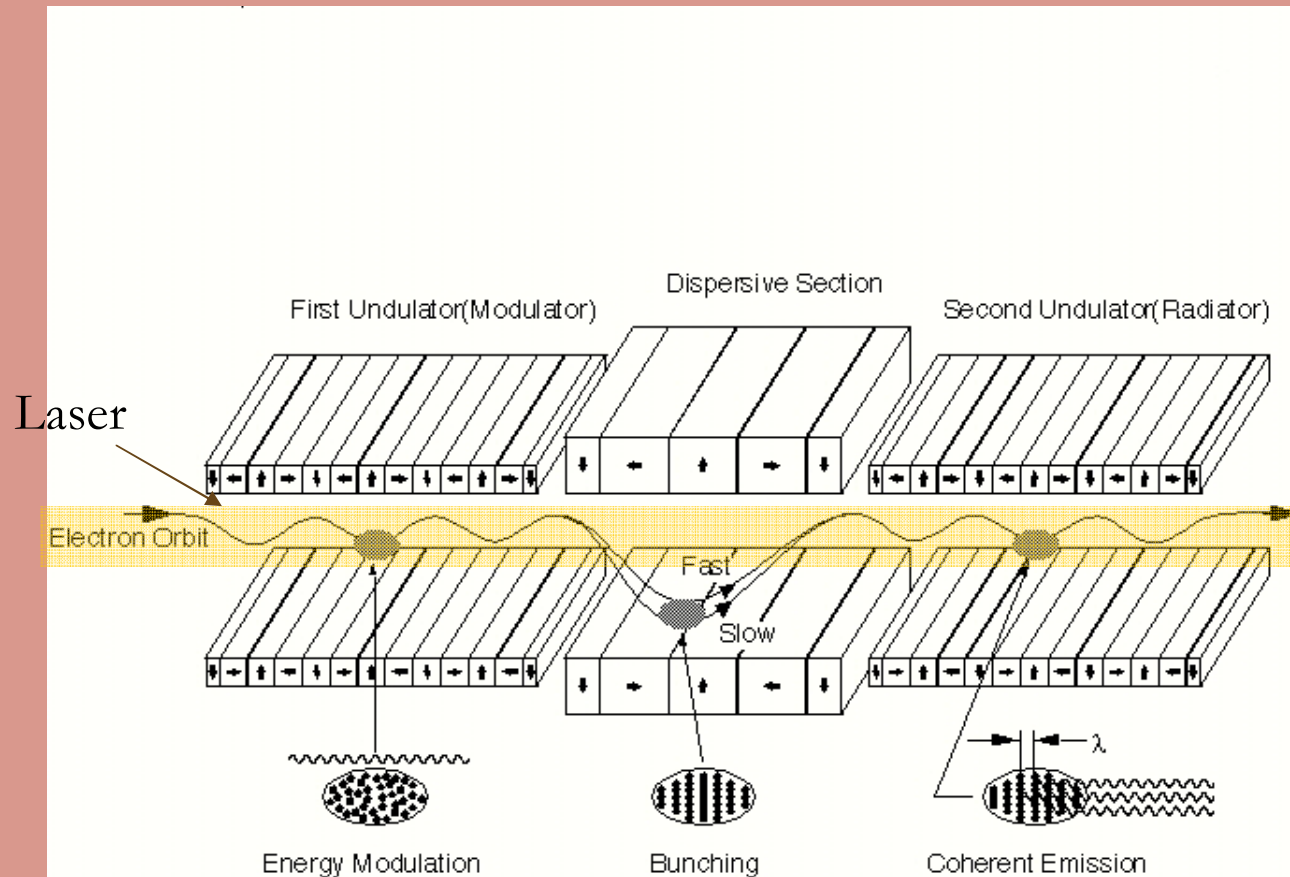
# What is Free Electron Laser ?

## Schematic of FEL system



Resonant wavelength: 
$$\lambda = \frac{\lambda_u}{2\gamma^2} \left( 1 + \frac{K^2}{2} \right)$$

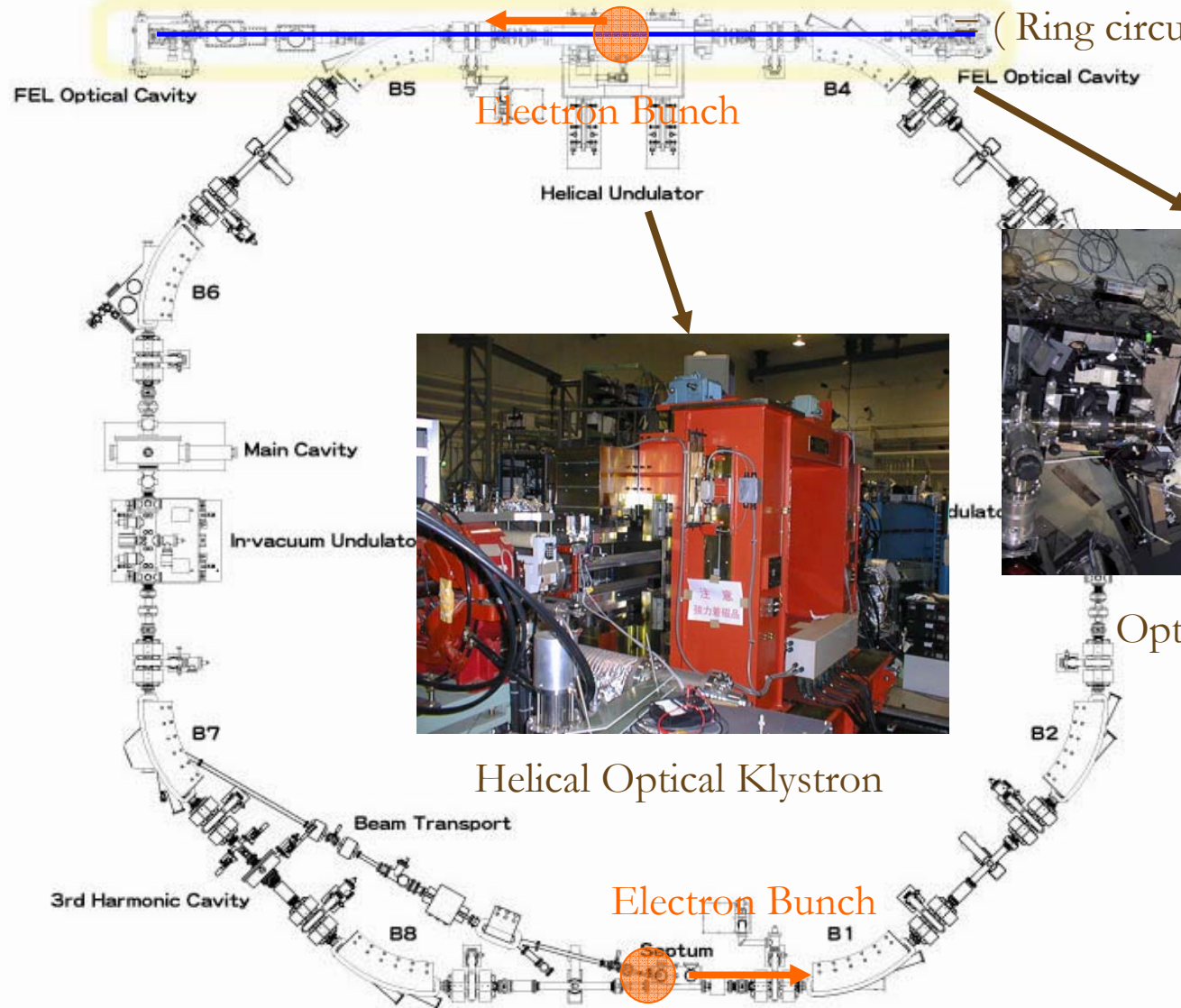
# Gain Mechanism of FEL using an Optical Klystron





# Storage ring FEL experiment at UVSOR

Optical cavity length = 13.3 m  
(Ring circumference)/4



Electron Bunch

Helical Undulator

FEL Optical Cavity

FEL Optical Cavity

Main Cavity

Invacuum Undulator

Optical Cavity

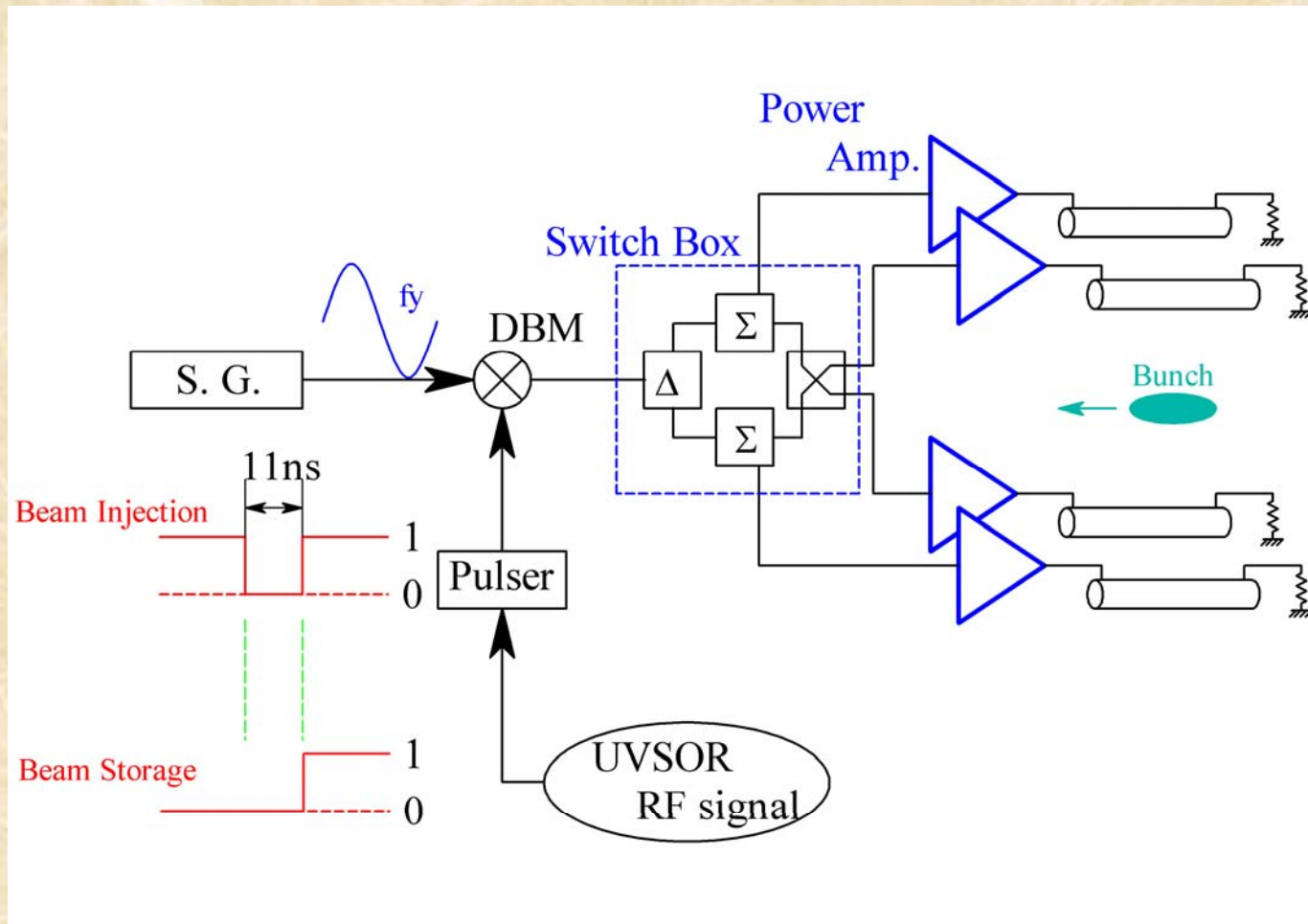
Helical Optical Klystron

Electron Bunch

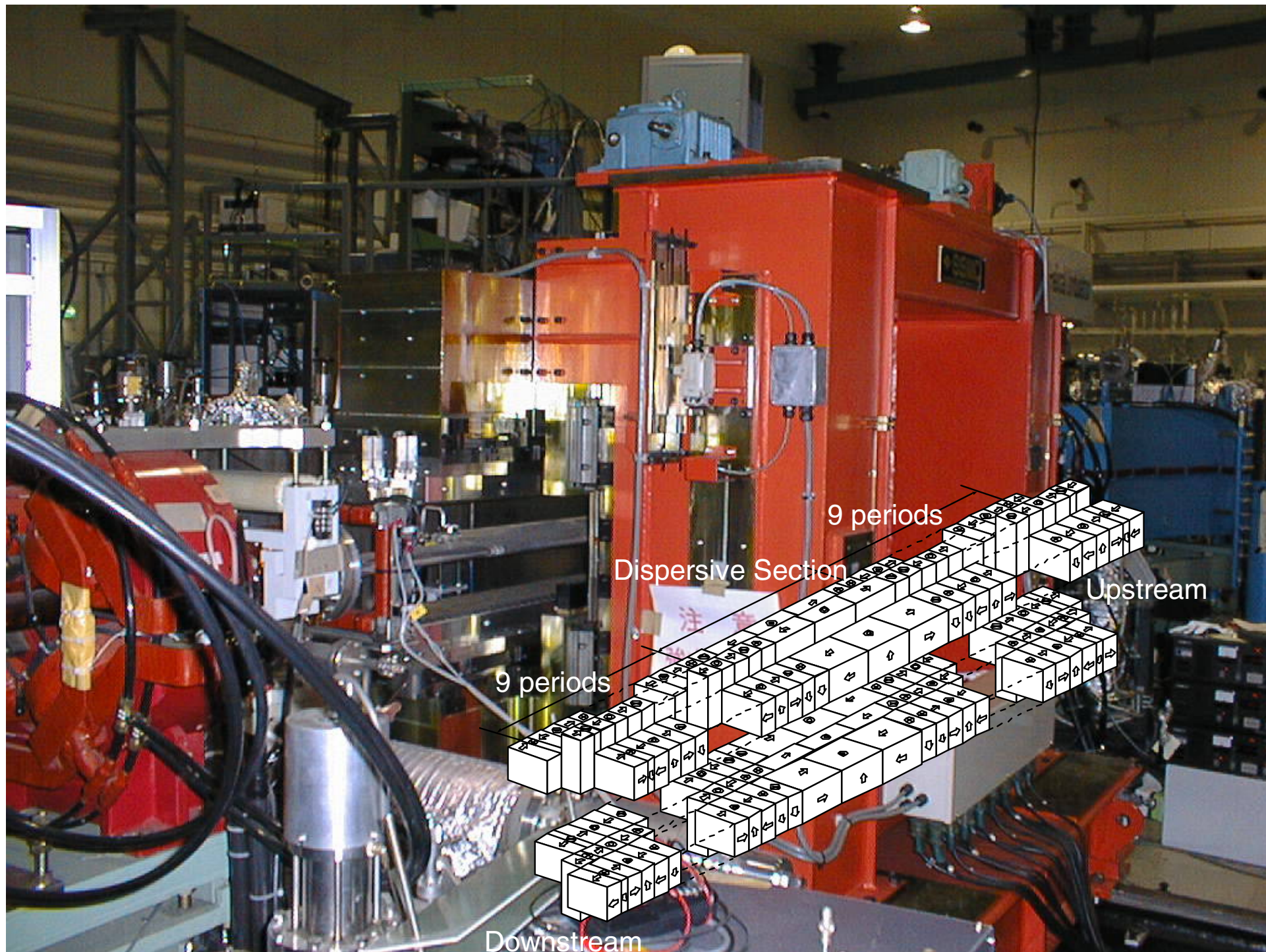
Septum

3rd Harmonic Cavity

Beam Transport



RF knock out system for single bunch operation



# Parameter of the FEL experiment

## Storage ring

Beam Energy	600 MeV (ordinary operation 750 MeV)
Emittance	18 nm-rad (108 nm-rad before the upgrade)
Beam current	100 mA/bunch (Max)
Operation	Single bunch, 2 bunch, 4 bunch

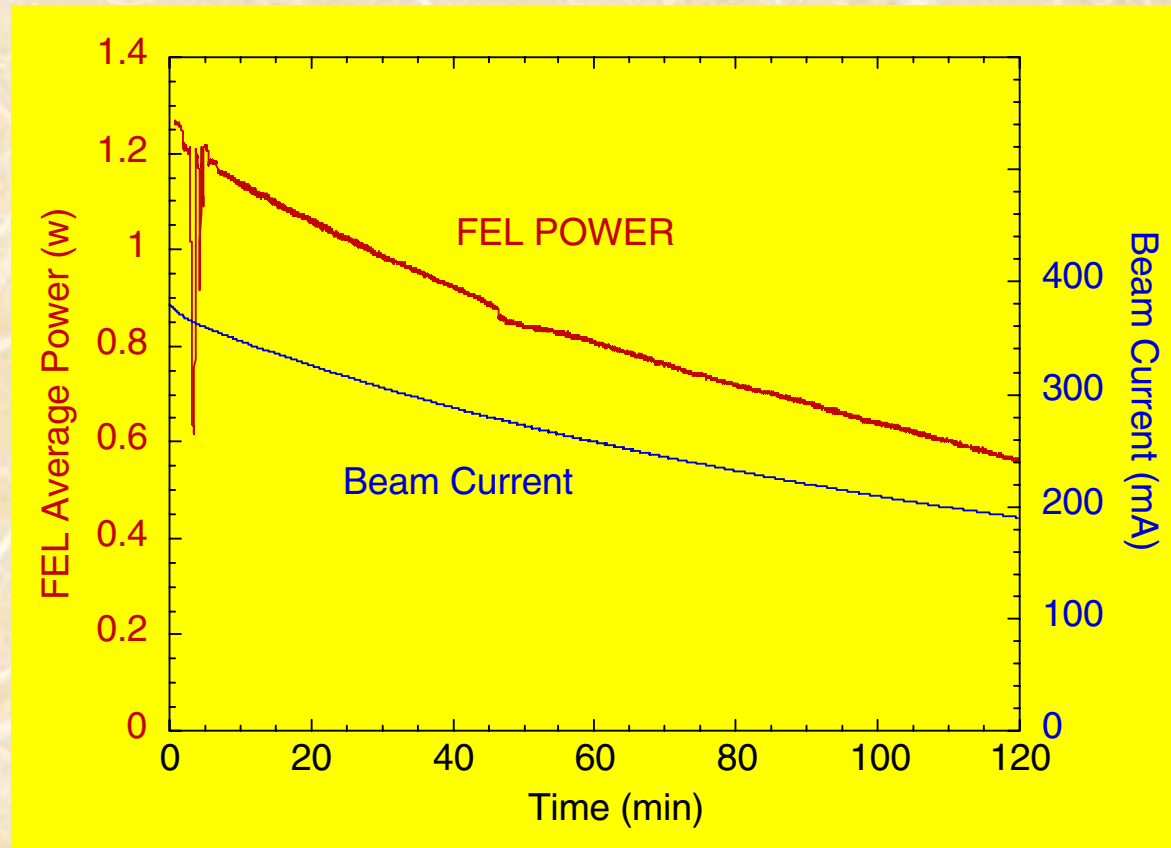
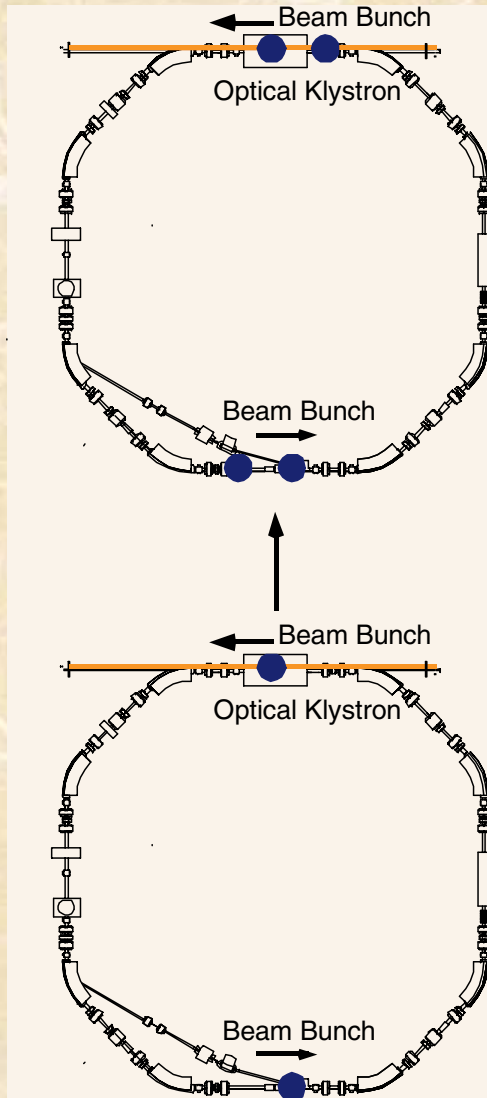
## Optical klystron

Type	Helical/Linear
Number of period	9+9
Period length	110 mm
K-value	4.6>(Helical)/8.5>(linear)

## Optical Cavity

Type	Fabry-Perot
Length	13.3 m
Mirror	Multi-layers ( $\text{HfO}_2/\text{SiO}_2$ , $\text{Ta}_2\text{O}_5/\text{SiO}_2$ )

# High power operation



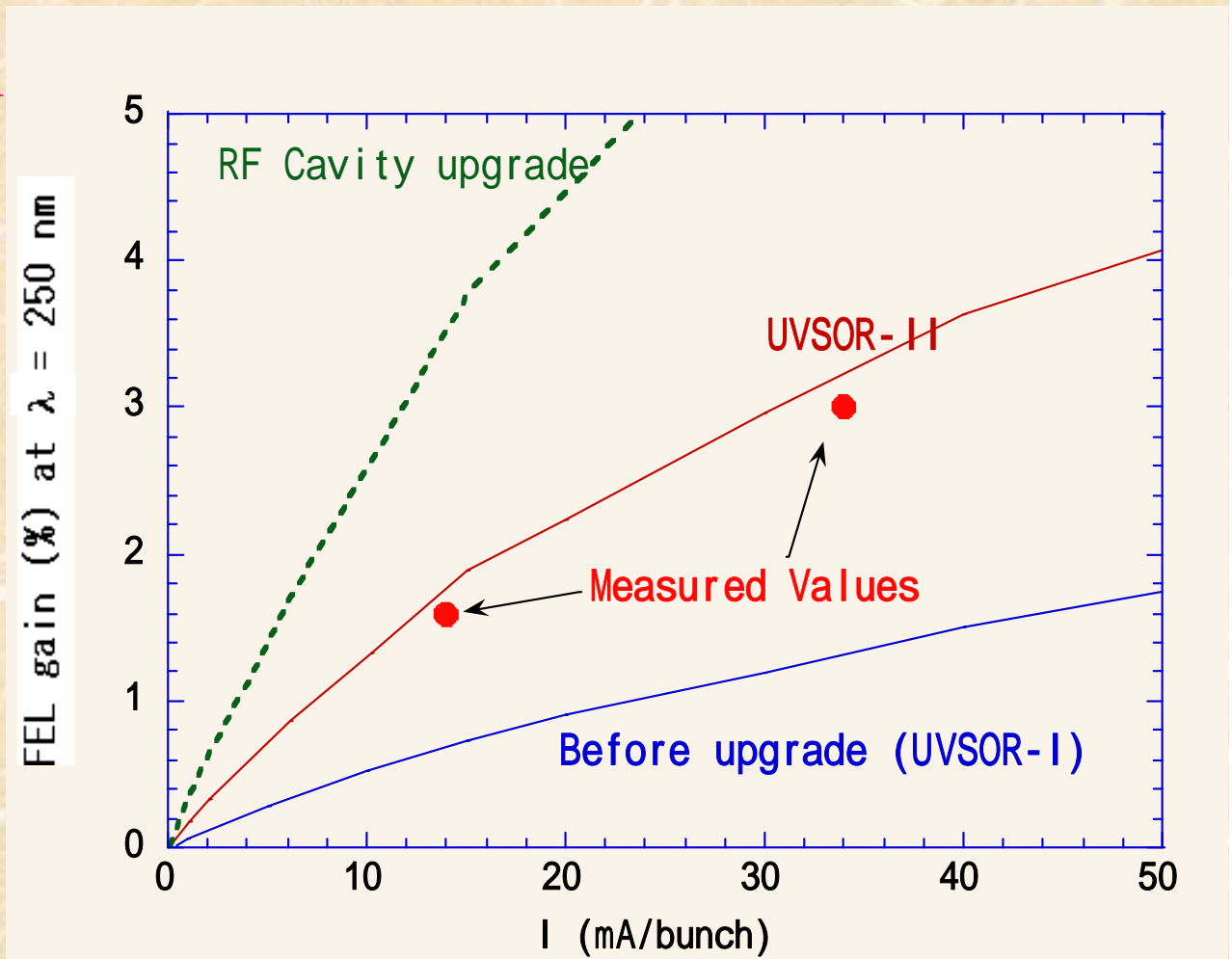
- High beam current ( $\sim 100\text{mA}/\text{bunch}$ )
- Optimization of cavity mirrors
- 4 bunch operation

# FEL with upgraded UVSOR-II storage ring

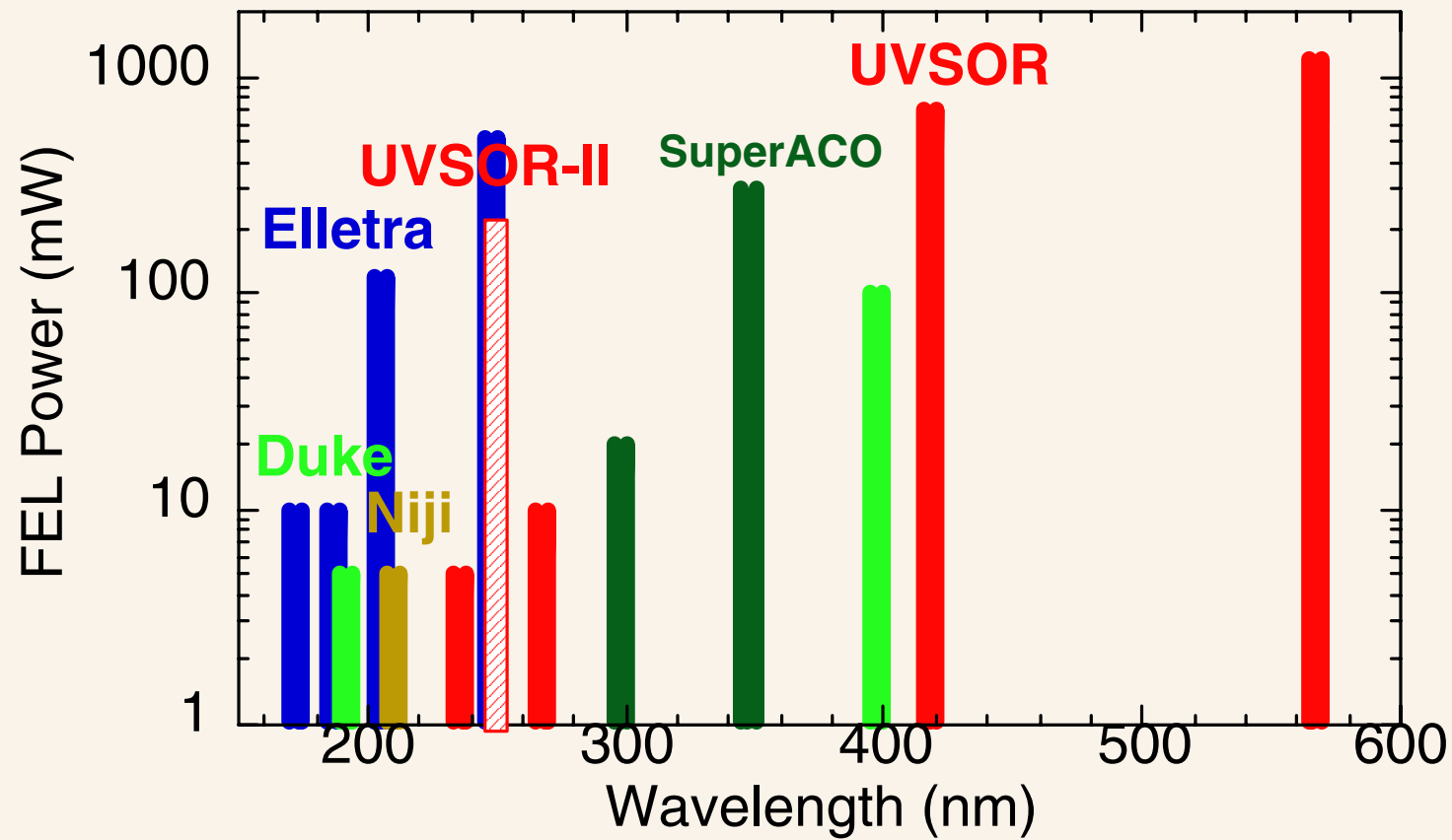
Upgrade of UVSOR  
(2003).

Beam emittance  
110 nmrad  $\longrightarrow$  18 nmrad

More than 2 times higher gain



# Storage ring FEL in the world



# User experiment of the UVSOR-FEL

## Advantages of UVSOR-FEL

- Natural synchronization with SR pulse
- Good temporal features ( $\sigma_{\tau} < 10\text{ps}$ )
- Good coherence ( $\Delta\lambda/\lambda \sim 1/5000$ )
- Covering a wide range of wavelength (Infra-red  $\sim$  UV)
- High power ( $\sim 1\text{W}$ )
- Switch polarization (right circular, left circular, liner)
- High intra-cavity power ( $\sim \text{kW}$ )

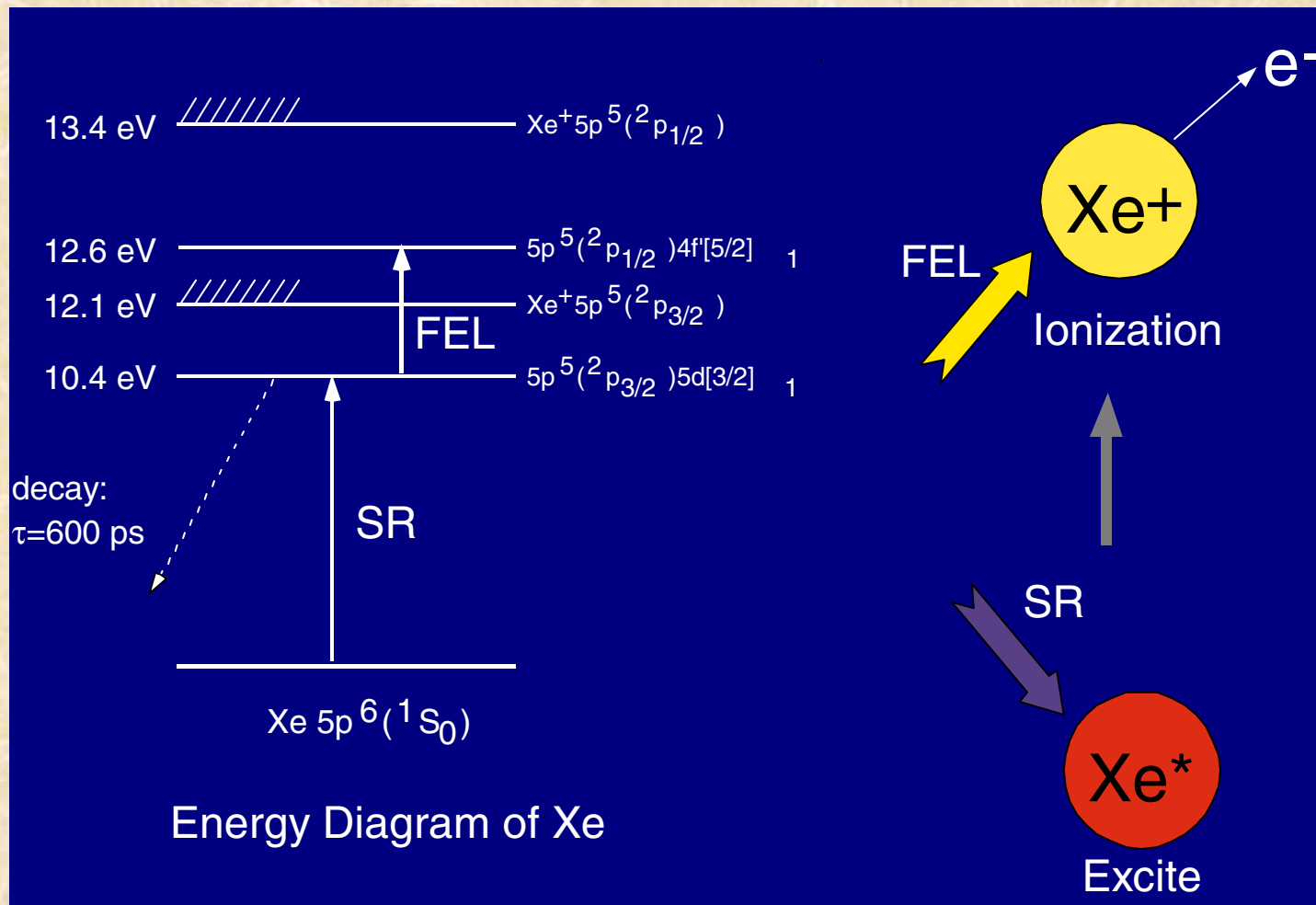


## Application

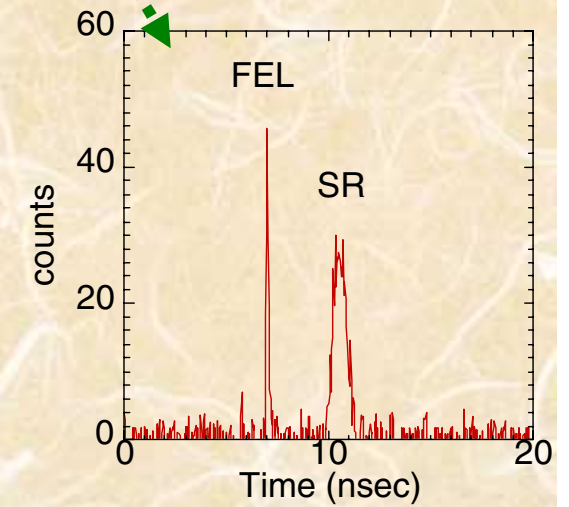
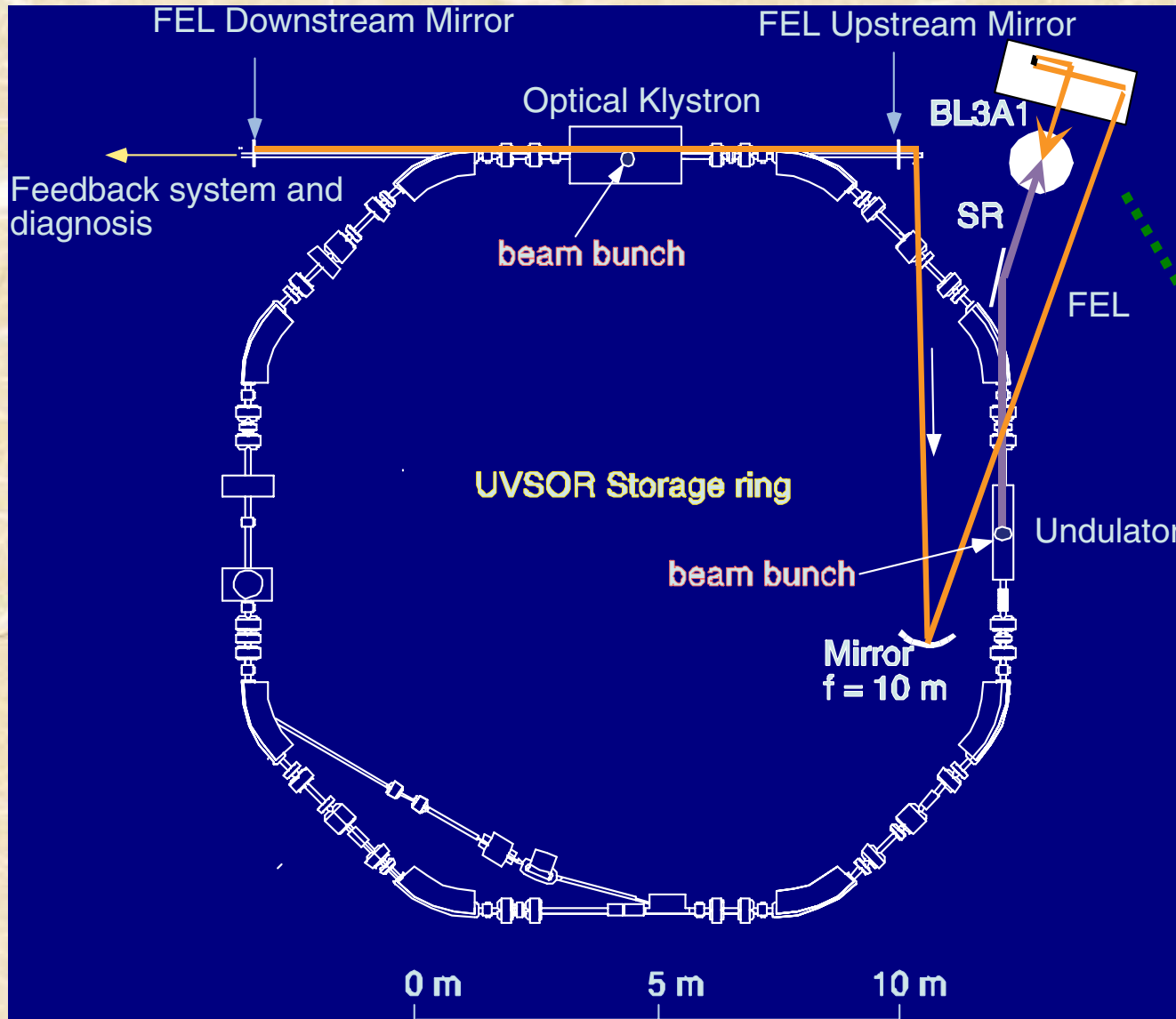
- Pump/Probe experiment
- Chirality experiment (bio-molecule)
- Production of high energy  $\gamma$ -ray

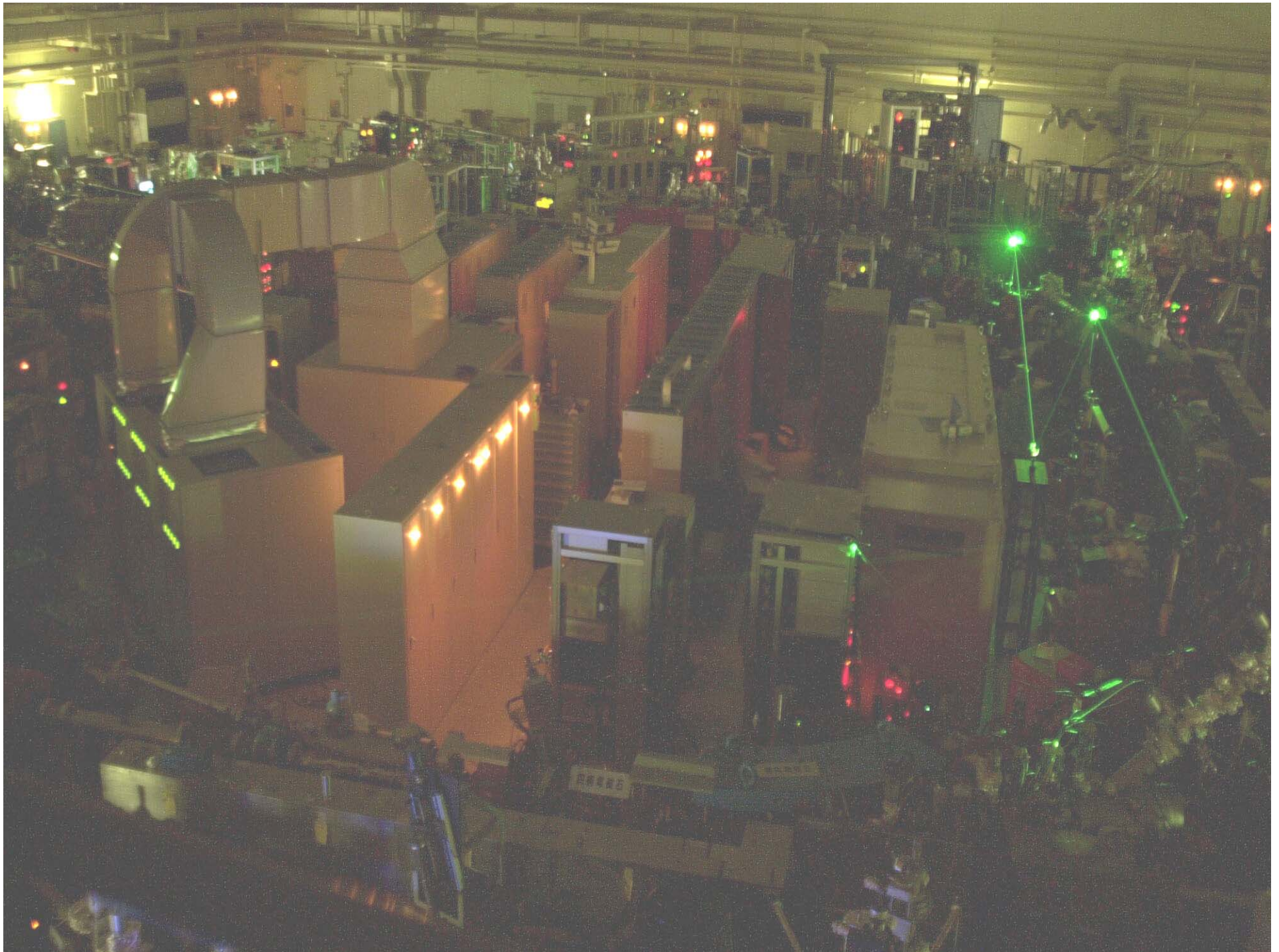


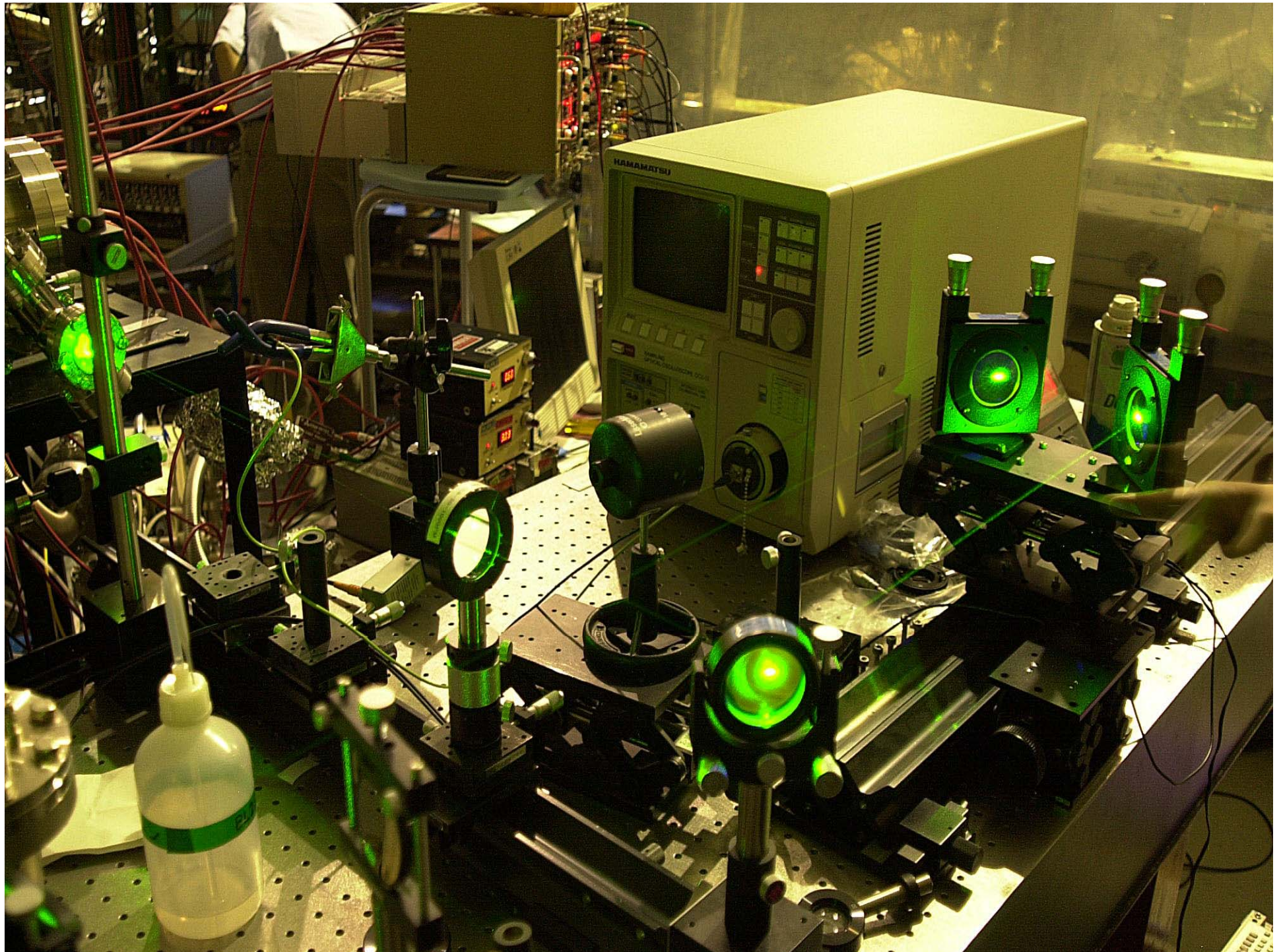
# Pump/probe experiment on Xe



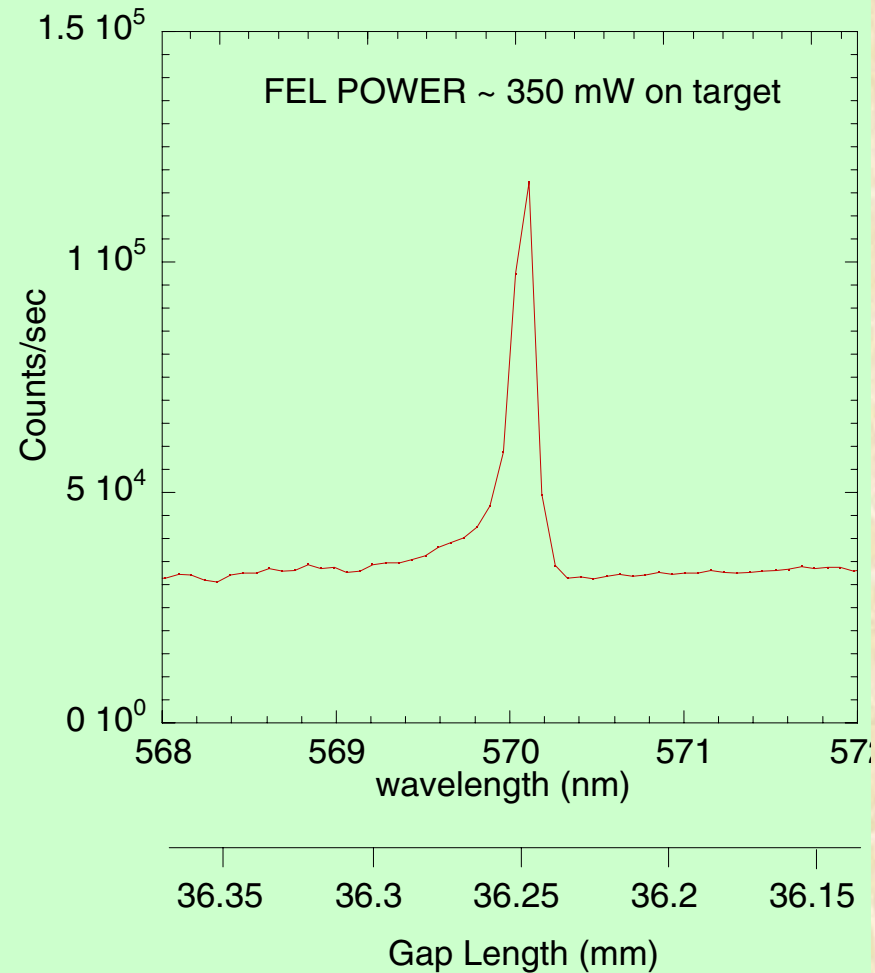
# Experimental setup







# Experimental result

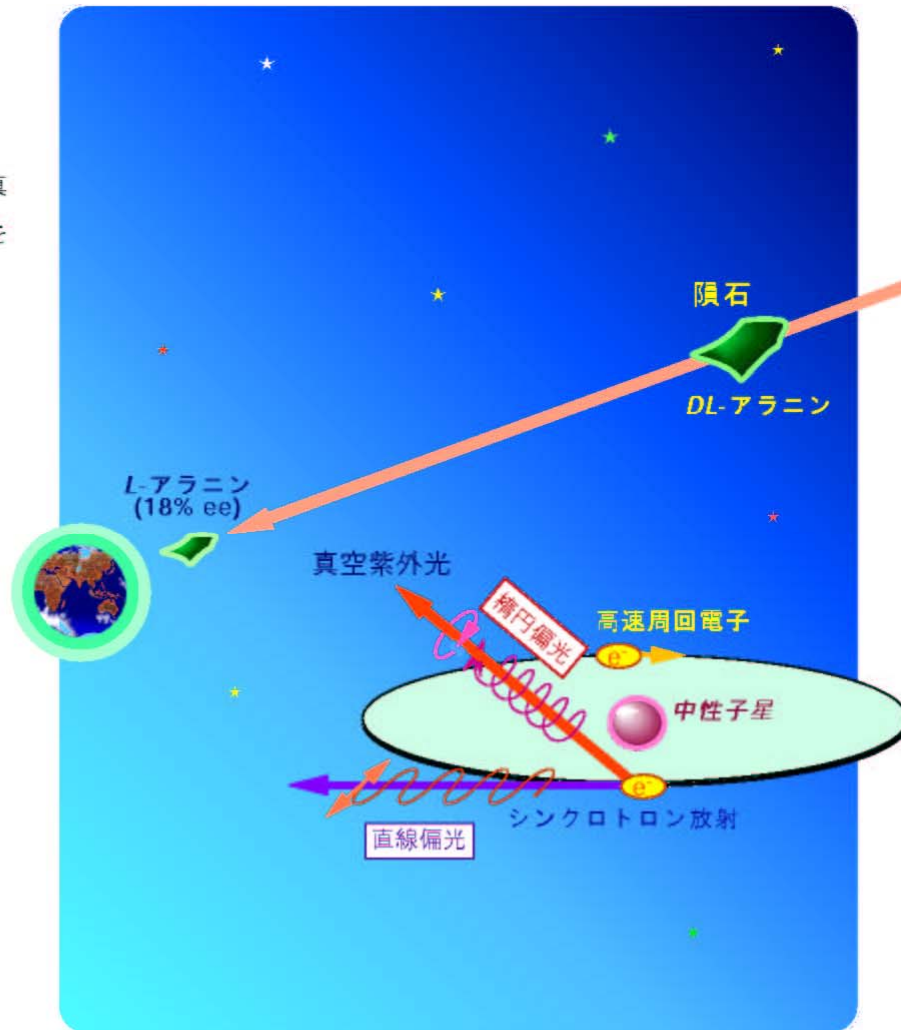
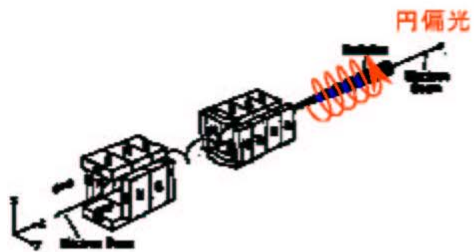


- FEL Wavelength ~ 570 nm and ~420 nm
- Ions produced in double resonant reaction are detected as a function of FEL wavelength.
- FEL wavelength is swept by changing the gap length of the optical klystron.

Spectrum of a doubly excited stat of Xe

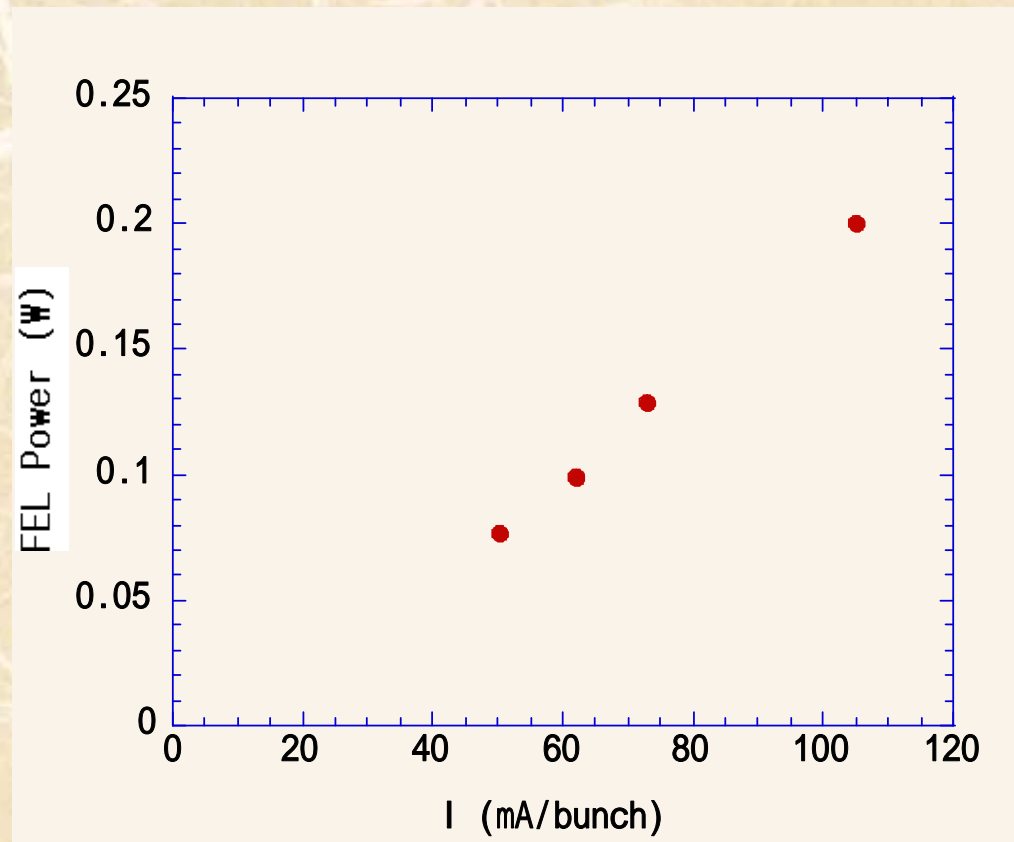
# Origin of biomolecular homochirality

宇宙におけるキラリティー誕生のシナリオ  
超新星爆発後に出来る中性子星を周回する高速電子からシンクロトロン放射（楕円偏光）による絶対不斉合成をヘリカルアンジュレータ（真空紫外円偏光発生用シンクロトロン挿入光源）を用いてシミュレートする



ICORP Entropy Control Project

## Origin of biomolecular homochirality (Cont.)

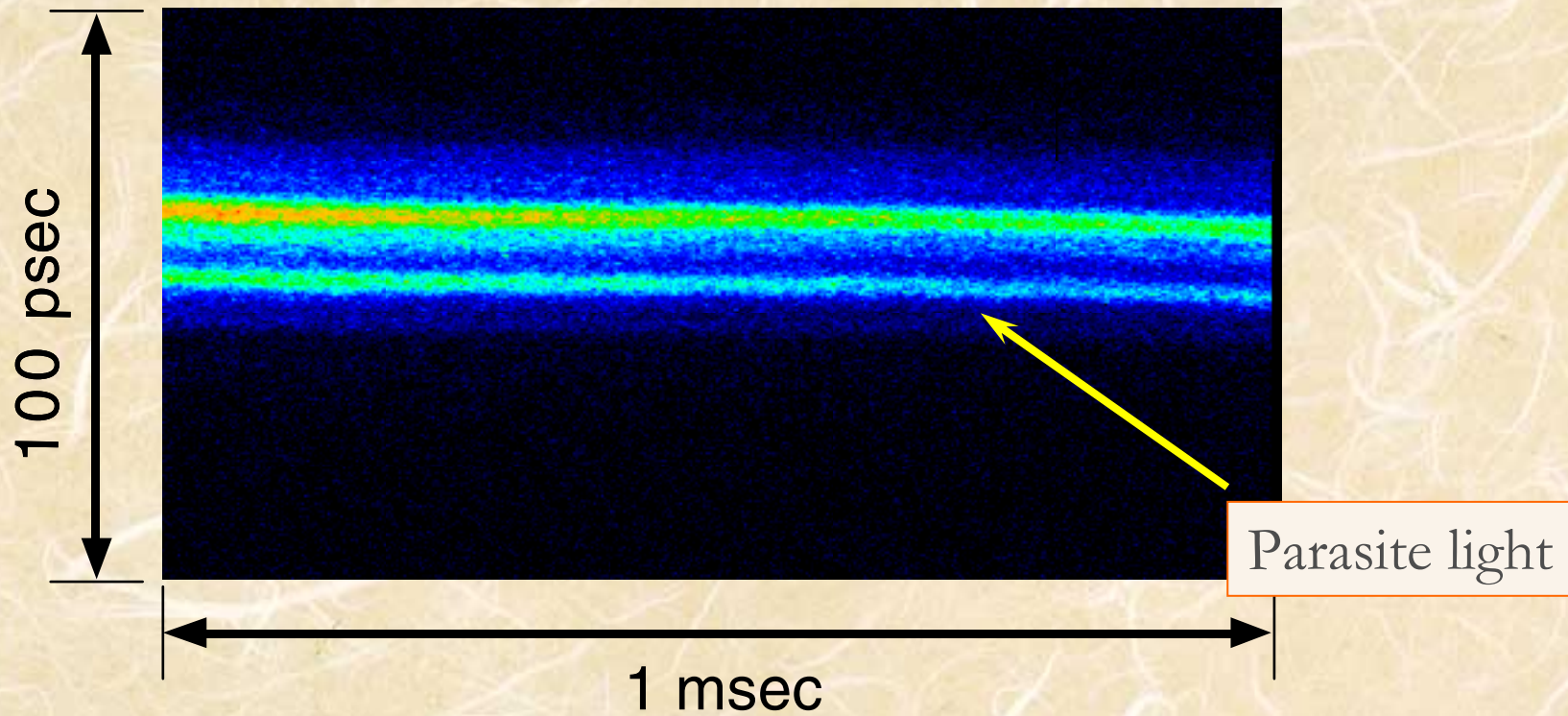


- Irradiate a sample with right and left circular FEL
- FEL wavelength
  - (1) 250 nm (Mar. 5<sup>th</sup> 2005)
  - (2) 215 nm

FEL power at  $\lambda = 250$  nm

# Temporal Characteristics of Storage ring FEL

Streak camera image in the CW zone

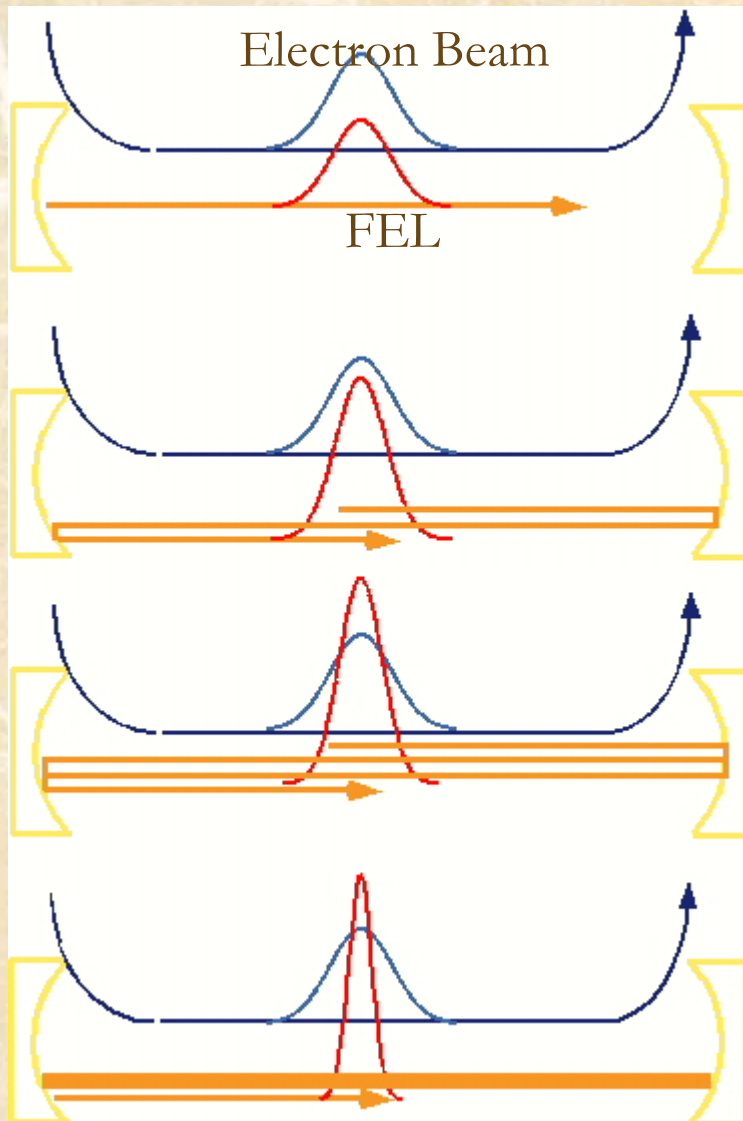


Measured time duration  $\sim 3\text{psec} \ll$  Bunch Length (100 ~ 400 ps)

Why ?



# Mechanism of temporal narrowing



## Incoherent radiation

$$I_{\text{FEL}} \propto \exp(-(\tau/\sigma_{\text{beam}})^2/2) \quad \sigma_{\tau} = \sigma_{\text{Beam}},$$

Gain  $\propto$  Beam Density

### 1 Round Trip

$$I_{\text{FEL}} \propto \exp(-(\tau/\sigma_{\text{beam}})^2/2)^2 = \exp(-(\tau/(\sigma_{\text{beam}}/2))^2/2)$$

$$\sigma_{\tau} = \sigma_{\text{Beam}}/2,$$

### 2 Round Trip

$$\sigma_{\tau} = \sigma_{\text{Beam}}/3$$

### n Round Trip

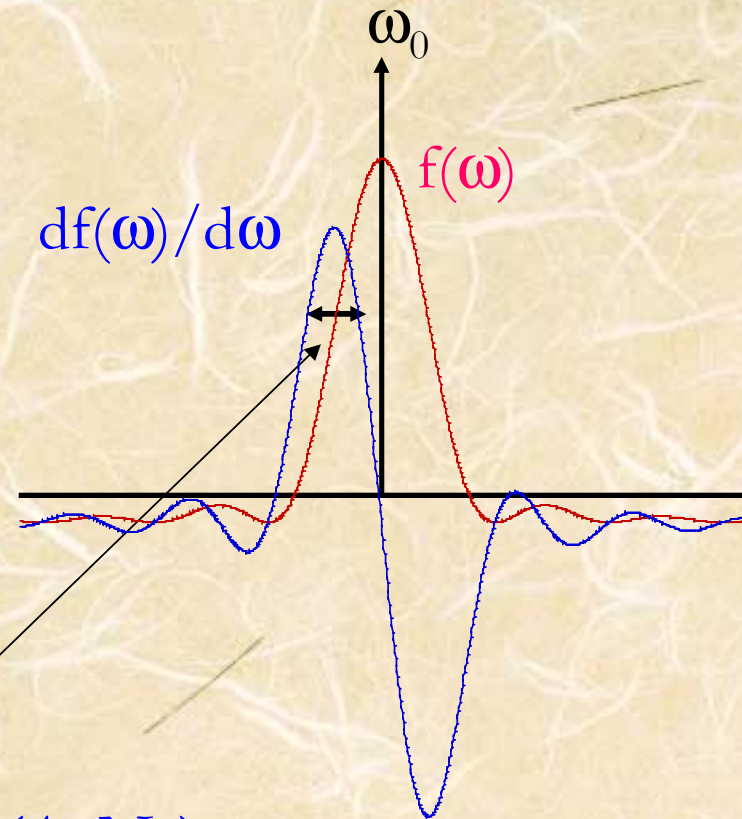
$$\sigma_{\tau} = \sigma_{\text{Beam}}/n,$$

# Spectral narrowing

Mayday's theorem:

FEL gain  $(\omega) \propto df(\omega) / d\omega$

$f(\omega)$ : Spectrum of spontaneous radiation from undulator



1 Round trip

$$\sigma_{sp} = \Delta\omega = \omega_0 / (4\pi N_u)$$

2 Round trip

$$\sigma_{\omega} = \Delta\omega / 2$$

$$\Delta\omega = \omega_0 / (4\pi N_u)$$

$N_u$ : Number of periods of undulator

n-Round trip

$$\sigma_{\omega} = \Delta\omega / n = \omega_0 / (4\pi n N_u)$$

# Limitation of Narrowing

“n round trip”

$$\sigma_{\tau} = \sigma_{\text{beam}} / n$$
$$\sigma_{\omega} = \omega_0 / (4\pi n N_u)$$

Fourier Limit

$$\sigma_{\tau} \cdot \sigma_{\omega} > 1/2$$

$$: \sigma_{\tau} \cdot \sigma_{\omega} = \sigma_{\text{beam}} \omega_0 / (4\pi N_u n^2) > 1/2$$

$$n = (\sigma_{\text{beam}} \omega_0 / (2\pi N_u))^{1/2} \sim 100 : \text{narrowing saturate}$$

$$\sigma_{\tau} = (2\pi N_u \sigma_{\text{beam}} / \omega_0)^{1/2} = (N_u \sigma_{\text{beam}} \lambda / c)^{1/2}$$

$$\sigma_{\omega} = 0.5 (\omega_0 / (2\pi N_u \sigma_{\text{beam}}))^{1/2}$$

# Supermode theory

$$\sigma_{\tau} = 0.5(N_u \lambda \sigma_{\text{beam}} / c)^{1/2} \quad \sigma_{\lambda} / \lambda = (\lambda / (N_u \sigma_{\text{beam}} c))^{1/2} / \pi$$

UVSOR:  $N_u = N + N_d \sim 100$ ,

$\lambda = 520 \text{ nm}$

$\sigma_{\text{beam}} = 100 \text{ psec}$

$\sigma_{\tau} \sim 4.2 \text{ psec}$  (measured 4 psec)

$\sigma_{\lambda} / \lambda \sim 1/10000$  (measured  $< 1/5000$ )

For shorter pulse FEL(UVSOR case)

- Smaller number of periods of the undulator  
→ Smaller gain ( not realistic)
- Shorter wavelength → 200 nm
- Shorter bunch length  
low alpha, high cavity voltage → 10psec

$$\sigma_{\tau} \sim 800 \text{ fsec}$$

# Future plane of the UVSOR-FEL

Lasing in the VUV region (200nm ~ 150nm)

- Oxides multi-layers can not be used for mirrors ( $\lambda < 190$  nm)
- Fluoride ( ex  $\text{CaF}_2/\text{MgF}_2$  ) multi-layers

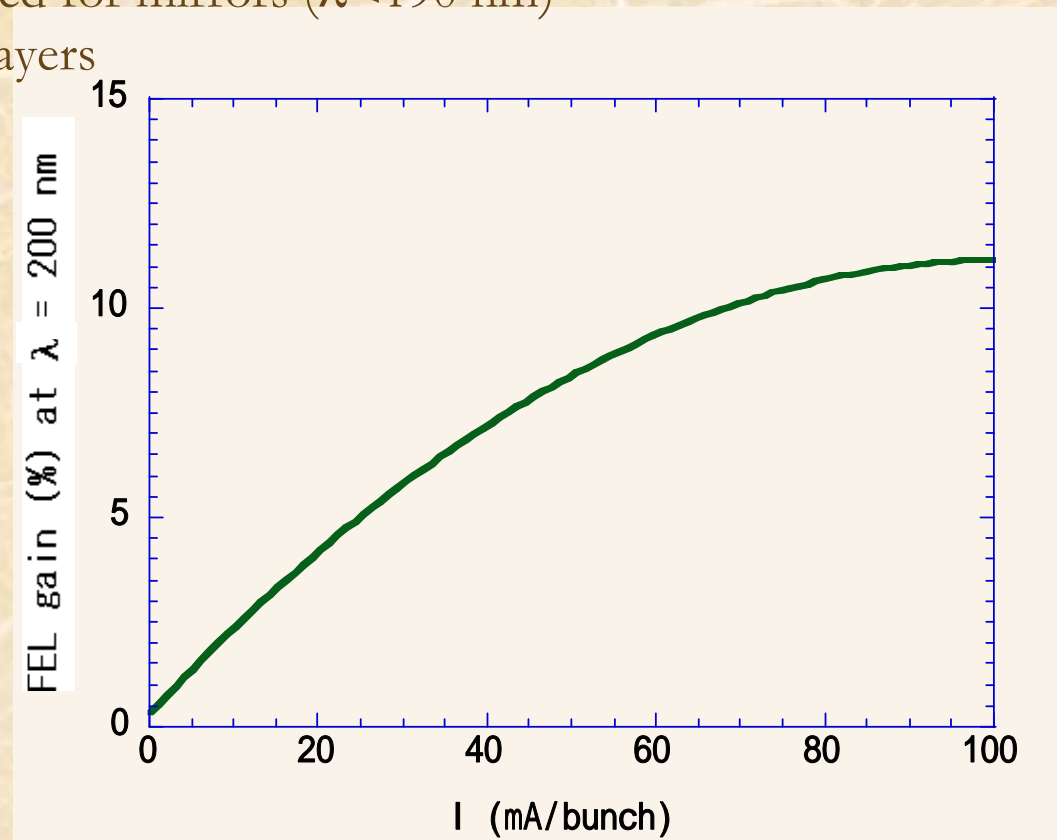


Reflectivity is small ~ 90 %

Upgrade of RF cavity

55 kV → 150 ~ 200 kV

Gain is doubled.



Expected FEL gain with upgraded RF cavity

Lasing is possible in the VUV